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group consisting of aluminum, titanium, tantalum, niobium, zirconium, silicon, thorium, cadmium and tungsten.

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B/21*
34. (Amended) An electrode comprising:
an electrically conductive substrate; and
a discontinuous non-anodized layer, of an oxide of a first
valve metal, on a surface of said substrate.

REMARKS

This Amendment is being filed to amend the claims to point out certain preferred embodiments of the invention.

Respectfully submitted,


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Marked up copy of claims which shows deleted subject matter in brackets and added subject matter underlined:

29. (Amended) A[n] non-anodized article of manufacture [comprising a valve metal] having a fractal [-like] surficial structure which includes both valve metal and an oxide thereof, the valve metal being selected from the group consisting of aluminum, titanium, tantalum, niobium, zirconium, silicon, thorium, cadmium and tungsten.

34. (Amended) An electrode comprising:
[(a)] an electrically conductive substrate; and
[(b)] a discontinuous non-anodized layer, of an oxide of a first valve metal, on a surface of said substrate.

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